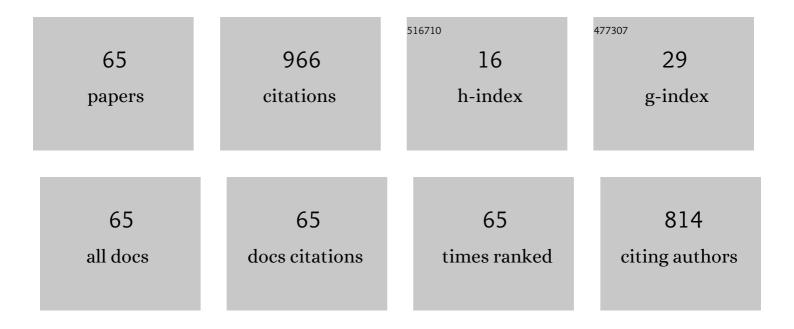
## Junbo Wang

List of Publications by Year in descending order

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#	Article	IF	CITATIONS
1	A Resonant High-Pressure Sensor Based on Integrated Resonator-Diaphragm Structure. IEEE Sensors Journal, 2022, 22, 3920-3927.	4.7	3
2	Advance of microfluidic constriction channel system of measuring <scp>singleâ€cell</scp> cortical tension/specific capacitance of membrane and conductivity of cytoplasm. Cytometry Part A: the Journal of the International Society for Analytical Cytology, 2022, 101, 434-447.	1.5	6
3	A MEMS-Based Co-Oscillating Electrochemical Vector Hydrophone. Micromachines, 2022, 13, 143.	2.9	0
4	A MEMS Electrochemical Angular Accelerometer Leveraging Silicon-Based Three-Electrode Structure. Micromachines, 2022, 13, 186.	2.9	2
5	Microfluidic Quantitative Flow Cytometer With Light Modulation. IEEE Sensors Journal, 2022, 22, 3009-3016.	4.7	2
6	A Mems Based Electrochemical Angular Accelerometer with a High-Integrated Sensing Unit. , 2022, , .		0
7	A Bulk-Micromachined Resonant Differential Pressure Microsensor Insensitive to Temperature and Static Pressure. , 2022, , .		3
8	A Resonant Low-Pressure Microsensor With Low Temperature Disturbance. IEEE Sensors Journal, 2022, 22, 10404-10410.	4.7	2
9	A Low-Temperature-Sensitivity Resonant Pressure Microsensor Based on Eutectic Bonding. IEEE Sensors Journal, 2022, 22, 9321-9328.	4.7	3
10	A MEMS Electrochemical Seismometer Based on the Integrated Structure of Centrosymmetric Four Electrodes. Micromachines, 2022, 13, 354.	2.9	0
11	Reduction of Temperature Sensitivity for Resonant Micro-Pressure Sensor Using Glass-Silicon Coupling Wafer Packaging. IEEE Sensors Journal, 2022, 22, 6410-6417.	4.7	1
12	A Resonant Differential Pressure Microsensor With Stress Isolation and Au-Au Bonding in Packaging. IEEE Transactions on Electron Devices, 2022, 69, 2023-2029.	3.0	6
13	Development of Microfluidic System Enabling High-Throughput Characterization of Multiple Biophysical Parameters of Single Cells. IEEE Transactions on Electron Devices, 2022, 69, 2015-2022.	3.0	3
14	Development of droplet microfluidics capable of quantitative estimation of single-cell multiplex proteins. Journal of Micromechanics and Microengineering, 2022, 32, 024002.	2.6	5
15	An Electrostatic Comb Excitation Resonant Pressure Sensor for High Pressure Applications. IEEE Sensors Journal, 2022, 22, 15759-15768.	4.7	3
16	A Microfluidic Platform for Characterizing Single-Cell Intrinsic Bioelectrical Properties With Large Sample Size. IEEE Transactions on Electron Devices, 2022, 69, 5177-5184.	3.0	1
17	A new electrochemical angular microaccelerometer with integrated sensitive electrodes perpendicular to flow channels. Microsystems and Nanoengineering, 2022, 8, .	7.0	2
18	An Electrochemical Angular Micro-Accelerometer Based on Miniaturized Planar Electrodes Positioned in Parallel. IEEE Sensors Journal, 2021, 21, 21305-21313.	4.7	7

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19	The Design and Fabrication of the High Integrated Sensitive Electrodes by Adopting the Anodic Bonding Technology for the Electrochemical Seismic Sensors. , 2021, , .		5
20	Quantification of Single-Cell Cortical Tension Using Multiple Constriction Channels. IEEE Sensors Journal, 2021, 21, 7260-7267.	4.7	4
21	A droplet-based microfluidic flow cytometry enabling absolute quantification of single-cell proteins leveraging constriction channel. Microfluidics and Nanofluidics, 2021, 25, 1.	2.2	10
22	A High-Sensitivity Resonant Differential Pressure Microsensor Based on Bulk Micromachining. IEEE Sensors Journal, 2021, 21, 8927-8934.	4.7	19
23	Temperature Compensation of the MEMS-Based Electrochemical Seismic Sensors. Micromachines, 2021, 12, 387.	2.9	4
24	A Micromachined Electrochemical Angular Accelerometer Based on Interdigital Electrodes. , 2021, , .		2
25	A MEMS-Based Electrochemical Angular Accelerometer With a Force-Balanced Negative Feedback. IEEE Sensors Journal, 2021, 21, 15972-15978.	4.7	12
26	MEMS-Based Integrated Triaxial Electrochemical Seismometer. Micromachines, 2021, 12, 1156.	2.9	3
27	A Resonant Differential Pressure Microsensor With Temperature and Static Pressure Compensations. IEEE Sensors Journal, 2021, 21, 19881-19888.	4.7	6
28	A Micromachined Resonant Low-Pressure Sensor With High Quality Factor. IEEE Sensors Journal, 2021, 21, 19840-19846.	4.7	8
29	A Micromachined Resonant Micro-Pressure Sensor. IEEE Sensors Journal, 2021, 21, 19789-19796.	4.7	5
30	The MEMS-Based Electrochemical Seismic Sensor With Integrated Sensitive Electrodes by Adopting Anodic Bonding Technology. IEEE Sensors Journal, 2021, 21, 19833-19839.	4.7	6
31	Microfluidic Cytometry for Highâ€Throughput Characterization of Single Cell Cytoplasmic Viscosity Using Crossing Constriction Channels. Cytometry Part A: the Journal of the International Society for Analytical Cytology, 2020, 97, 630-637.	1.5	11
32	A novel microfluidic flow-cytometry for counting numbers of single-cell β-actins. Nami Jishu Yu Jingmi Gongcheng/Nanotechnology and Precision Engineering, 2020, 3, 156-161.	3.2	2
33	Development of microfluidic platform capable of characterizing cytoplasmic viscosity, cytoplasmic conductivity and specific membrane capacitance of single cells. Microfluidics and Nanofluidics, 2020, 24, 1.	2.2	6
34	Development of microfluidic platform to high-throughput quantify single-cell intrinsic bioelectrical markers of tumor cell lines, subtypes and patient tumor cells. Sensors and Actuators B: Chemical, 2020, 317, 128231.	7.8	20
35	A MEMS-Based Electrochemical Angular Accelerometer With Integrated Plane Electrodes for Seismic Motion Monitoring. IEEE Sensors Journal, 2020, 20, 10469-10475.	4.7	17
36	The Electrochemical Seismometer Based on Fine-Tune Sensing Electrodes for Undersea Exploration. IEEE Sensors Journal, 2020, 20, 8194-8202.	4.7	10

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37	Wireless Passive Intracranial Pressure Sensor Based on Vacuum Packaging. IEEE Sensors Journal, 2020, 20, 11247-11255.	4.7	9
38	Development of microfluidic platform capable of high-throughput absolute quantification of single-cell multiple intracellular proteins from tumor cell lines and patient tumor samples. Biosensors and Bioelectronics, 2020, 155, 112097.	10.1	17
39	A Micromachined Resonant Differential Pressure Sensor. IEEE Transactions on Electron Devices, 2020, 67, 640-645.	3.0	21
40	Advances of Single-Cell Protein Analysis. Cells, 2020, 9, 1271.	4.1	27
41	Microelectromechanical System-Based Electrochemical Seismometers with Two Pairs of Electrodes Integrated on One Chip. Sensors, 2019, 19, 3953.	3.8	7
42	Crossing constriction channel-based microfluidic cytometry capable of electrically phenotyping large populations of single cells. Analyst, The, 2019, 144, 1008-1015.	3.5	17
43	Optimization of LC sensor enabling wireless passive intracranial pressure monitoring. Microsystem Technologies, 2019, 25, 3437-3446.	2.0	3
44	The Electrochemical Seismometer Based on a Novel Designed Sensing Electrode for Undersea Exploration. , 2019, , .		3
45	Development of microfluidic impedance cytometry enabling the quantification of specific membrane capacitance and cytoplasm conductivity from 100,000 single cells. Biosensors and Bioelectronics, 2018, 111, 138-143.	10.1	74
46	Microfluidic Analyzer Enabling Quantitative Measurements of Specific Intracellular Proteins at the Single-Cell Level. Micromachines, 2018, 9, 588.	2.9	2
47	Absolute Copy Numbers of β-Actin Proteins Collected from 10,000 Single Cells. Micromachines, 2018, 9, 254.	2.9	5
48	A Microfluidic Fluorescent Flow Cytometry Capable of Quantifying Cell Sizes and Numbers of Specific Cytosolic Proteins. Scientific Reports, 2018, 8, 14229.	3.3	14
49	Specific membrane capacitance, cytoplasm conductivity and instantaneous Young's modulus of single tumour cells. Scientific Data, 2017, 4, 170015.	5.3	37
50	A low-sample-loss microfluidic system for the quantification of size-independent cellular electrical property—Its demonstration for the identification and characterization of circulating tumour cells (CTCs). Sensors and Actuators B: Chemical, 2017, 246, 29-37.	7.8	28
51	A High-Consistency Broadband MEMS-Based Electrochemical Seismometer With Integrated Planar Microelectrodes. IEEE Transactions on Electron Devices, 2017, 64, 3829-3835.	3.0	8
52	A microfluidic flow cytometer enabling absolute quantification of single-cell intracellular proteins. Lab on A Chip, 2017, 17, 3129-3137.	6.0	41
53	Membrane capacitance of thousands of single white blood cells. Journal of the Royal Society Interface, 2017, 14, 20170717.	3.4	14
54	A microfabricated 96â€well woundâ€healing assay. Cytometry Part A: the Journal of the International Society for Analytical Cytology, 2017, 91, 1192-1199.	1.5	6

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#	Article	IF	CITATIONS
55	An Electrochemical, Low-Frequency Seismic Micro-Sensor Based on MEMS with a Force-Balanced Feedback System. Sensors, 2017, 17, 2103.	3.8	14
56	Development of Microfluidic Systems Enabling High-Throughput Single-Cell Protein Characterization. Sensors, 2016, 16, 232.	3.8	22
57	A MEMS based electrochemical seismometer with a novel integrated sensing unit. , 2016, , .		3
58	Microelectromechanical Systems-Based Electrochemical Seismic Sensors With Insulating Spacers Integrated Electrodes for Planetary Exploration. IEEE Sensors Journal, 2016, 16, 650-653.	4.7	26
59	A Resonant Pressure Microsensor Capable of Self-Temperature Compensation. Sensors, 2015, 15, 10048-10058.	3.8	37
60	Microfluidic Impedance Flow Cytometry Enabling High-Throughput Single-Cell Electrical Property Characterization. International Journal of Molecular Sciences, 2015, 16, 9804-9830.	4.1	125
61	A MEMS Based Electrochemical Vibration Sensor for Seismic Motion Monitoring. Journal of Microelectromechanical Systems, 2014, 23, 92-99.	2.5	57
62	A micro electrochemical seismic sensor based on MEMS technologies. Sensors and Actuators A: Physical, 2013, 202, 85-89.	4.1	28
63	A microfluidic system enabling continuous characterization of specific membrane capacitance and cytoplasm conductivity of single cells in suspension. Biosensors and Bioelectronics, 2013, 43, 304-307.	10.1	55
64	A microfluidic system for cell type classification based on cellular size-independent electrical properties. Lab on A Chip, 2013, 13, 2272.	6.0	53
65	A MEMS based Seismic Sensor using the Electrochemical Approach. Procedia Engineering, 2012, 47, 362-365.	1.2	14